



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.010-US)

In the Application of: LUTZ ET AL.) Group Art Unit: 2814
Serial No: 10/698,258) Before
Filed: OCTOBER 31, 2003) Examiner: Le, Dung Anh
Title: ANTI-STICKTION TECHNIQUE FOR THIN FILM)
AND WAFER-BONDED ENCAPSULATED)
MICROELECTROMECHANICAL SYSTEMS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate of Mailing under 37 CFR 1.8

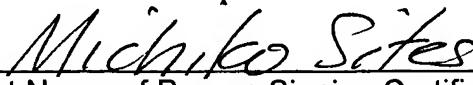
I hereby certify that the attached: (1) Amendment and Reply of February 23, 2005 (12 pages) + Abstract of the Disclosure (1 page), and (2) Replacement Sheets of Drawings (8 sheets) are being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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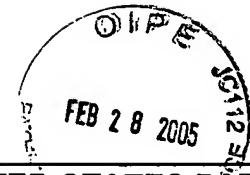
on February 23, 2005.



Signature



Print Name of Person Signing Certificate



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AMENDMENT AND REPLY OF FEBRUARY 23, 2005

Dear Sir:

Kindly amend the application as follows: